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SERIAL NUMBER | REQUEST DATE | FIRST NAMED APPLICANT

ATTORNEY DOCKET NO.

10/664,755

10/10/03

KUO-CHING LIU

NWAV 1002-2

Title:

METHOD AND APPARATUS FOR CUTTING DEVICES FROM SUBSTRATES

Art Unit Paper Number

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LICENSE FOR FOREIGN FILING

[Title 35, United States Code (1952) Sections 184, 185, 186]

Application No. 10/664,755

NWAV 1002-2 1460-130,00

CERTIFICATE OF TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence is being facsimile transmitted to United States Patent and Trademark Office at Fax No.

(703) 305-7658 on 10 October 2093. Kathryn Marley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kuo-Ching Liu

Application No.: 10/664,755

Filed: 17 September 2003

Title: METHOD AND APPARATUS FOR

CUTTING DEVICES FROM

SUBSTRATES

Art Unit: Unknown

Examiner: Unknown

CUSTOMER NO. 22470

Foreign Filing Department Commissioner for Patents Crystal Park 5, 3D11 P.O. Box 1450 Alexandria, VA 22313-1450

> PETITION FOR LICENSE UNDER 37 CFR §5.14; CORRESPONDING U.S. APPLICATION

Sir:

Applicant petitions for an Expedited Foreign Filing License on the above-identified application.

Pursuant to 37 C.F.R. Section 5.14, Applicant submits herewith a copy of the application which is to be filed in foreign countries. The specification differs from the above-referenced specification on file only to the extent that whenever "conductive" is referenced in the 14/14/2003 16 Specification of file, the specification for foreign filing replaces conductive with "conductive or semiconductive." The claims differ only in that there are additional claims which have been filed in a prior application for which a foreign filing license has already been granted (Application Serial No. 10/288,719).

> A PTO Form 2038 is enclosed herewith submitting \$130 to cover the petition fee pursuant to 37 C.F.R. Section 1.17(h).

It is requested that the License be faxed to the undersigned Mark A. Haynes at (650) 712-0263.

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7 3.5 3.50

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The Commissioner is hereby authorized to charge any additional fees which may be due, or credit any overpayment, to our Deposit Account No. 50-0869 (Order No. NWAV 1002-2).

Respectfully submitted,

Dated: 10 October 2003

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